

Mitigation of radon background by surface coating for the next generation of liquid xenon dark matter detectors

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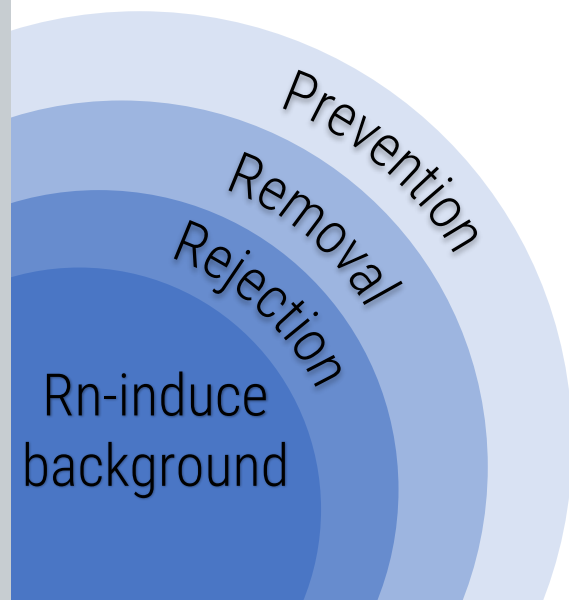
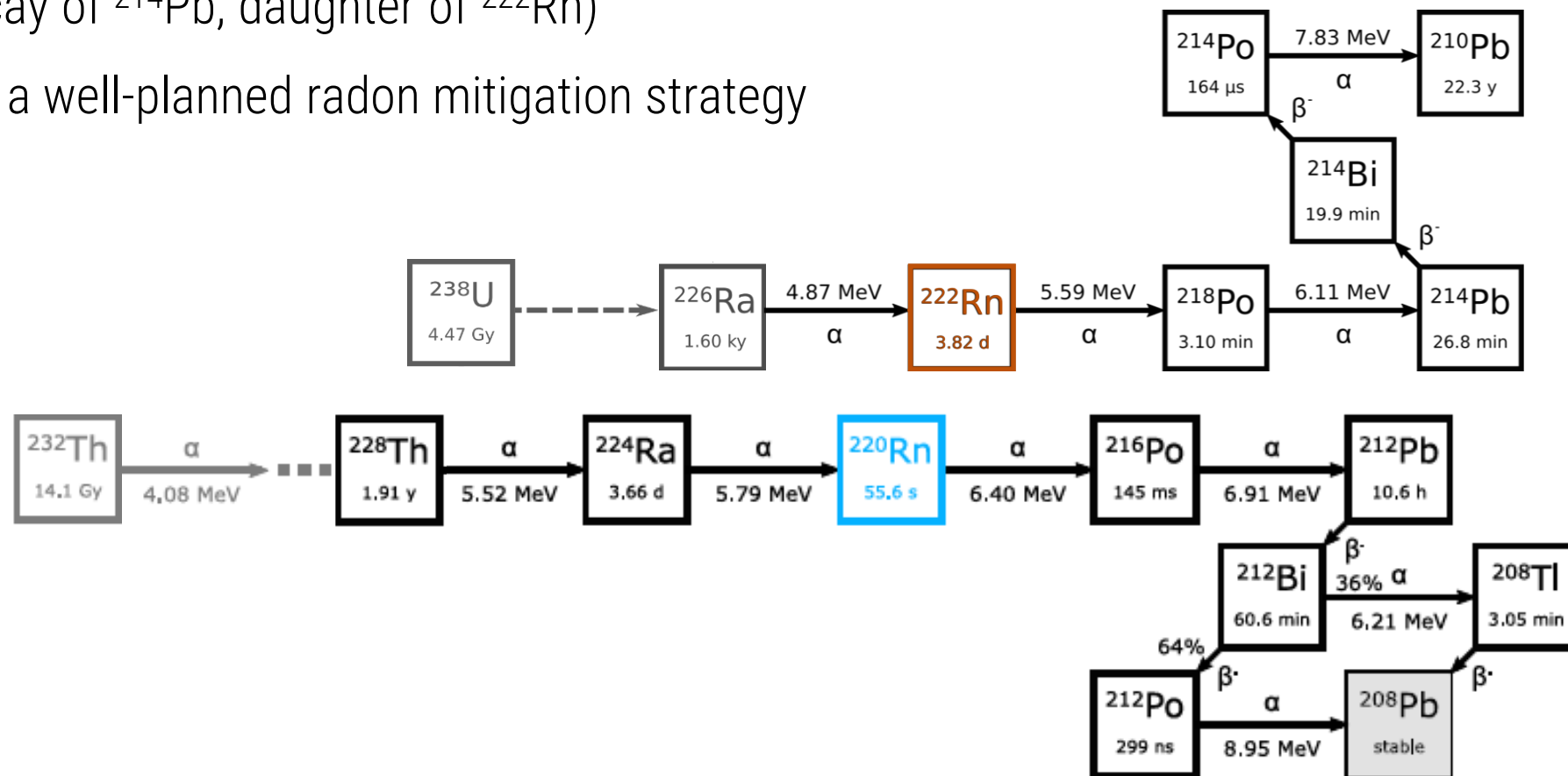
Technology and Instrumentation in Future Liquid Noble Gas Detectors

Kobayashi-Maskawa Institute, Nagoya



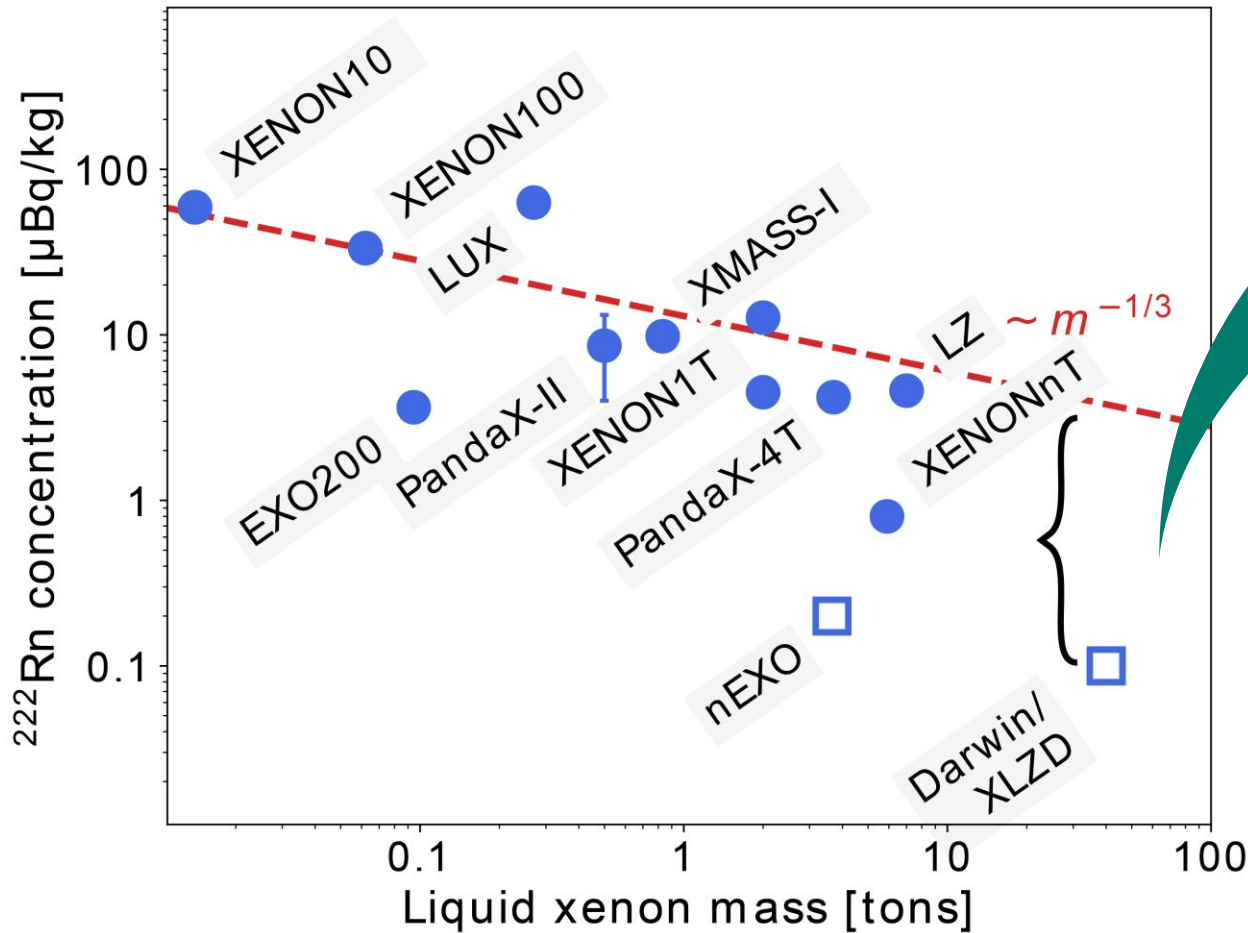
Radon background in rare event searches

- Rn-induced background are of great importance in many rare-event searches (e.g, dark matter)
- Radon atoms are found naturally in the environment and in detector components as part of U/Th decay chains.
- Radon progeny radioactive decay within the energy range of WIMP searches hampers detector sensitivity (e.g., β decay of ^{214}Pb , daughter of ^{222}Rn)
- Its reduction requires a well-planned radon mitigation strategy



Radon requirement for future Xe-based detectors

- DARWIN/XLZD (≥ 40 t active LXe volume) aims for $\times 10$ reduction in the radon content to probe WIMP-nucleon cross sections down to a few 10^{-49} cm² [1]
- The current technology and the volume dilution is not enough to reach ~ 0.1 μ Bq/kg



Largest background reduction challenge:

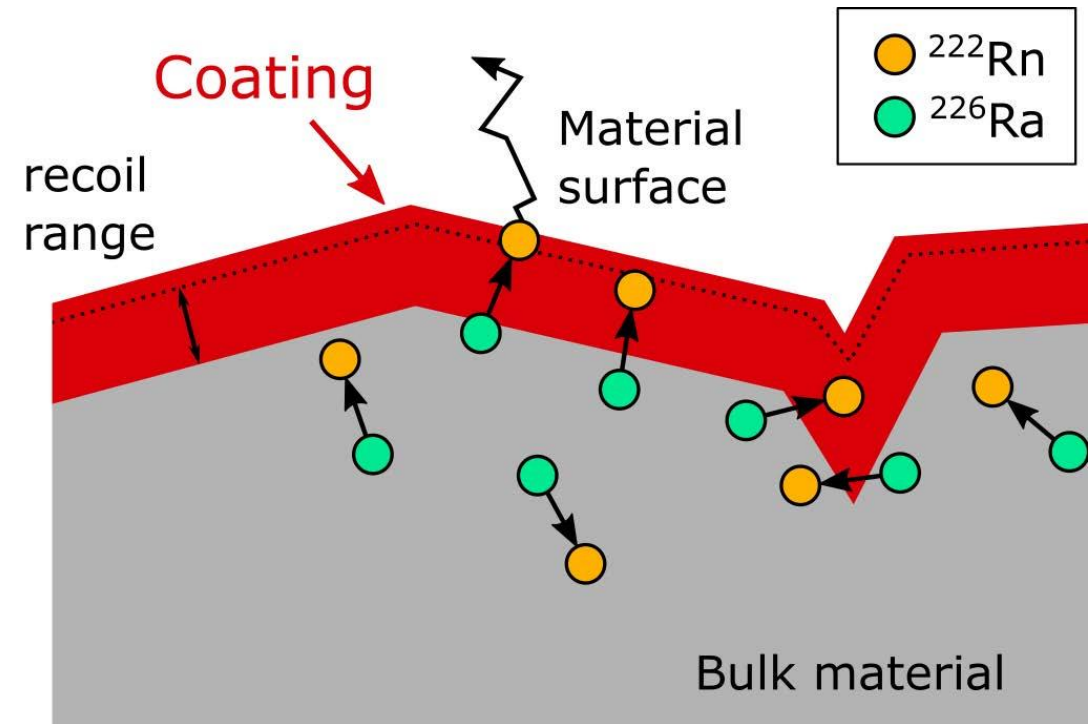
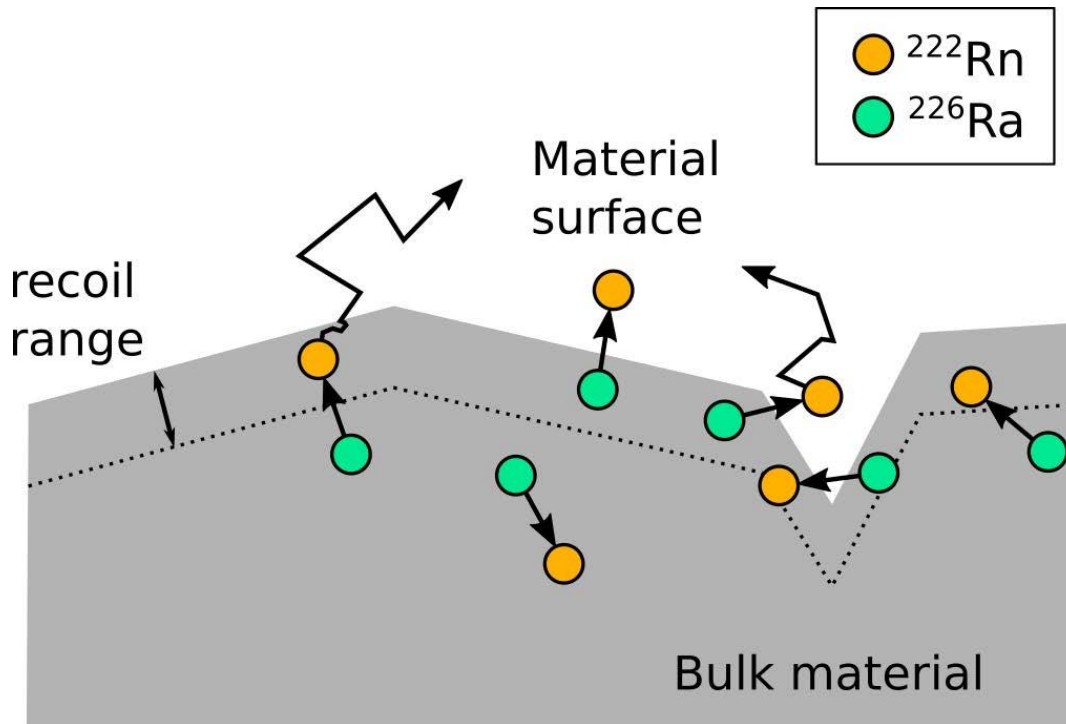
1. Aggressive ²²²Rn assay campaign previous detector construction
2. Improvement of current purification techniques
3. Prevention of Rn emanation into the target
4. ...

[1] Assuming a rejection of ERs at the 2×10^{-4} level at 30% NR acceptance



Surface coating: novel mitigation strategy

IDEA - Reduce the radon released from a material by a thin coating layer which seals its surface



REQUIREMENTS

- Thick enough to contain the radon recoil ($O(10\text{ nm})$) for $E_{\text{recoil energy}}^{222\text{Rn}} = 86.2\text{ keV}$, $E_{\text{recoil energy}}^{220\text{Rn}} = 103.4\text{ keV}$
- Sufficiently tight to prevent radon diffusion
- Must feature a high degree of radio purity, especially regarding ^{226}Ra

Investigated techniques

- Radon reduction factor R was investigated for several techniques using thoriated welding rods
- $R = A_{before} / A_{after}$, where A is ^{220}Rn (^{222}Rn) the activity measured using electrostatic radon monitor (proportional counters)

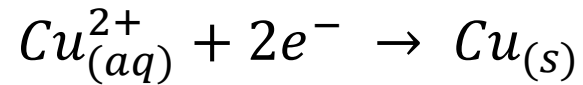


Method	Coating Material	Thickness [μm]	Reduction	
			^{220}Rn	^{222}Rn
Sputtering	Titanium	0.4 – 0.8	4.5	~ 2.1
Plasma spraying	Copper	3	22	//
Epoxy resin	Stycast	≈ 200	≥ 74	//
Chemical Vapor deposition	Diamon like carbon	1	3	~ 1.4
Electrochemical plating	Copper	5	150	~ 7.4

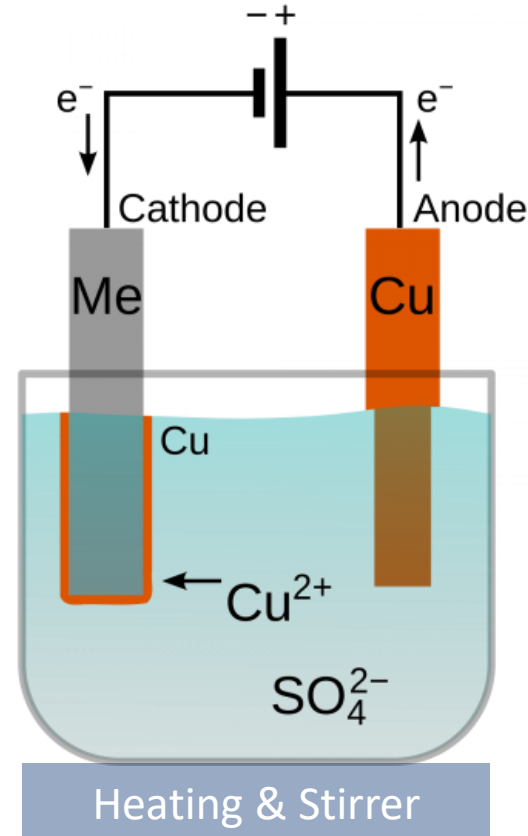
Electrochemical plating (EPC) of copper

- ECP of copper performed with a local setup at MPIK laboratory
- Motivated literature results on radiopure electro-formed copper
- Electrolyte: 0.05 mol/l CuSO_4 + 1 mol/l H_2SO_4
- Solution heated to $\sim 45^\circ\text{C}$ and continuously stirred

Reduction at the metal workpiece:



Best results obtained (for 5 μm layer) with
 $50 \text{ mA/cm}^2 \xrightarrow{1 \mu\text{m}} 10 \text{ mA/cm}^2$

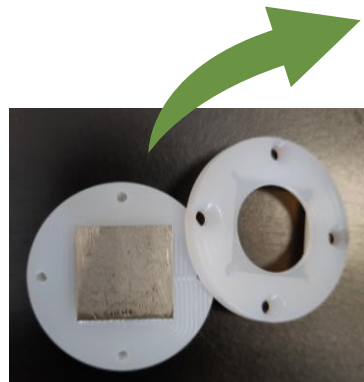




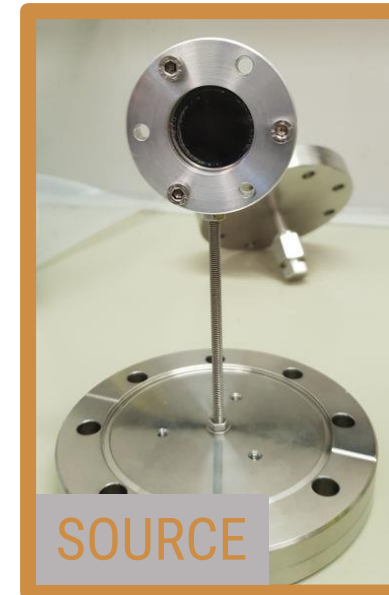
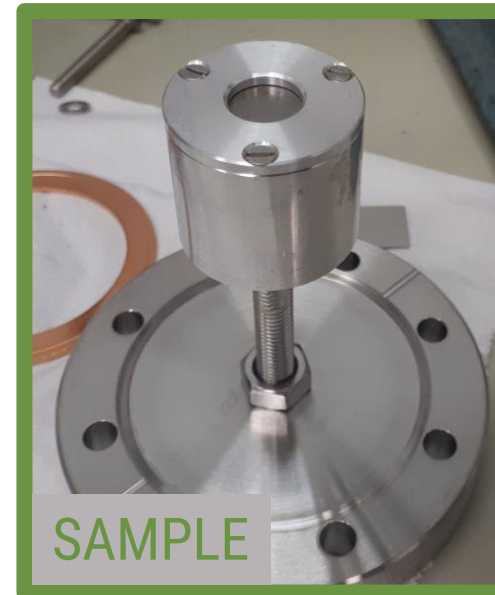
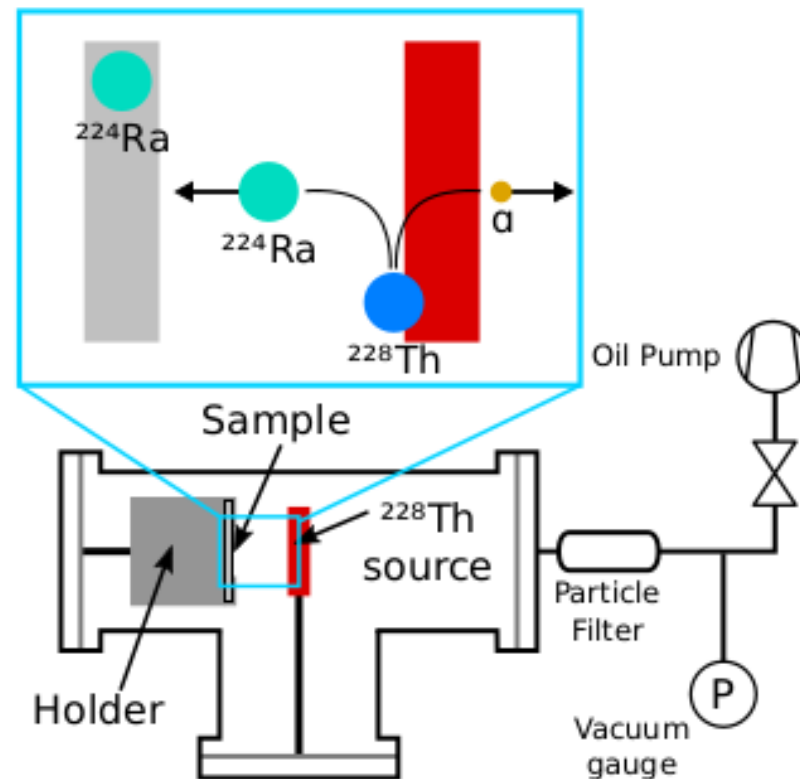
Giovanni Volta, 16 Feb 2024

Validation with ^{224}Ra implanted samples

- Reproducibility of ECP procedure on stainless steel^[1] verified using *homemade* ^{224}Ra recoil implanted stainless steel samples - $A_{\text{implanted}} = \mathcal{O}(10\text{Bq})$
- Rather superficial implantation and widely spread
- Challenging due to the short half-life of ^{224}Ra ($T_{1/2} \approx 3.6$ days)



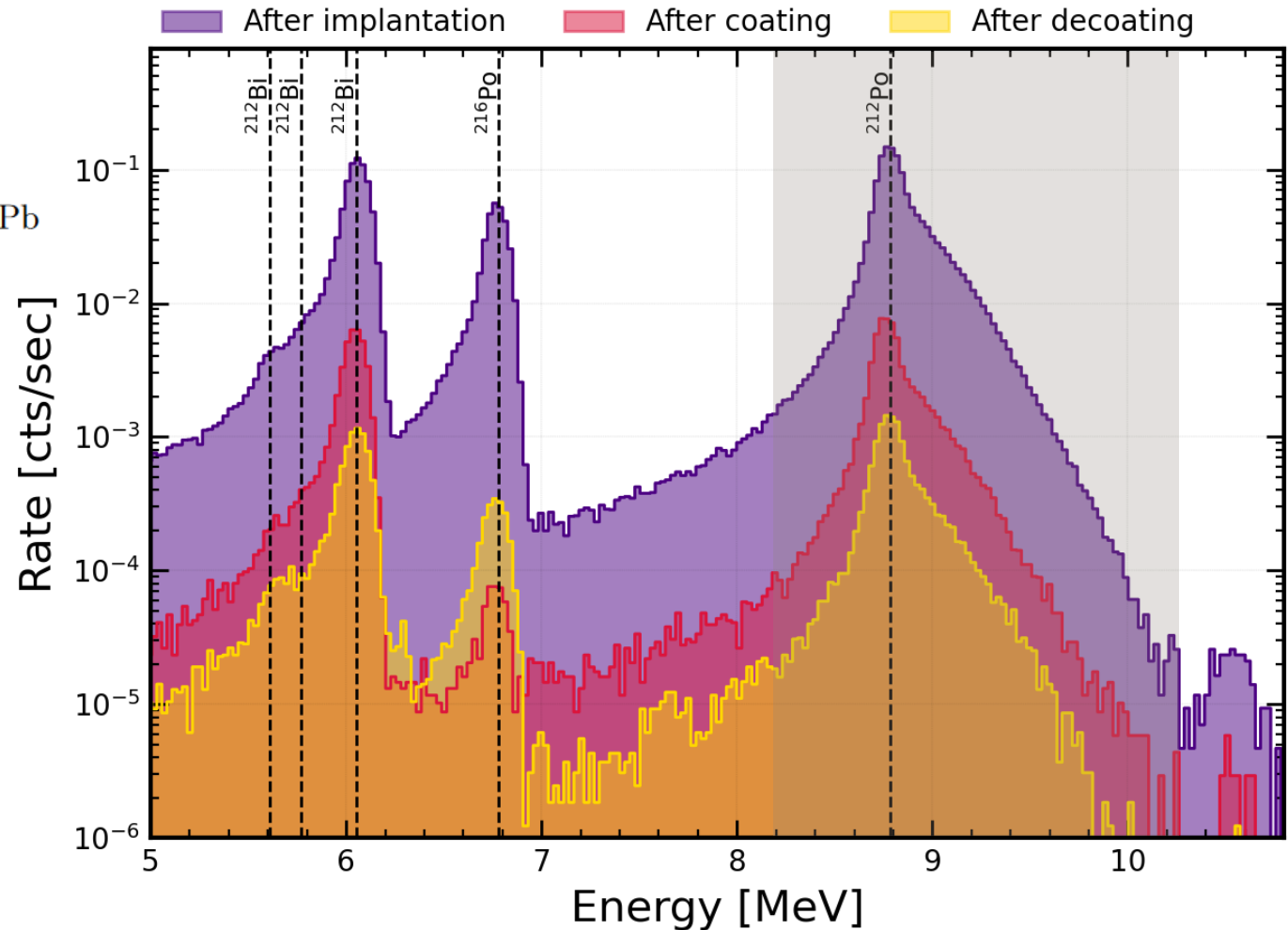
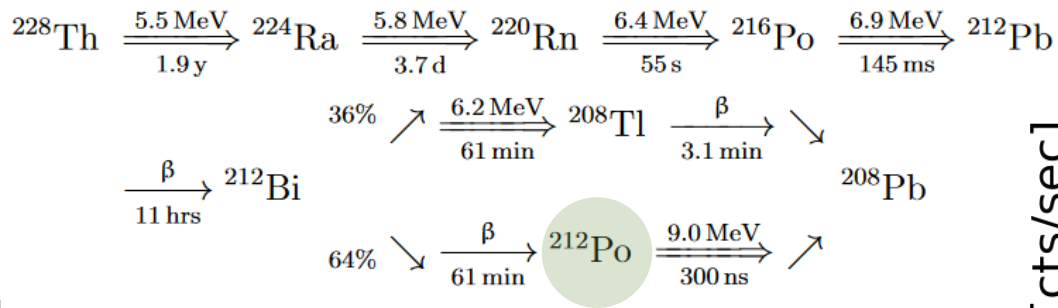
\Rightarrow ^{220}Rn emanation source



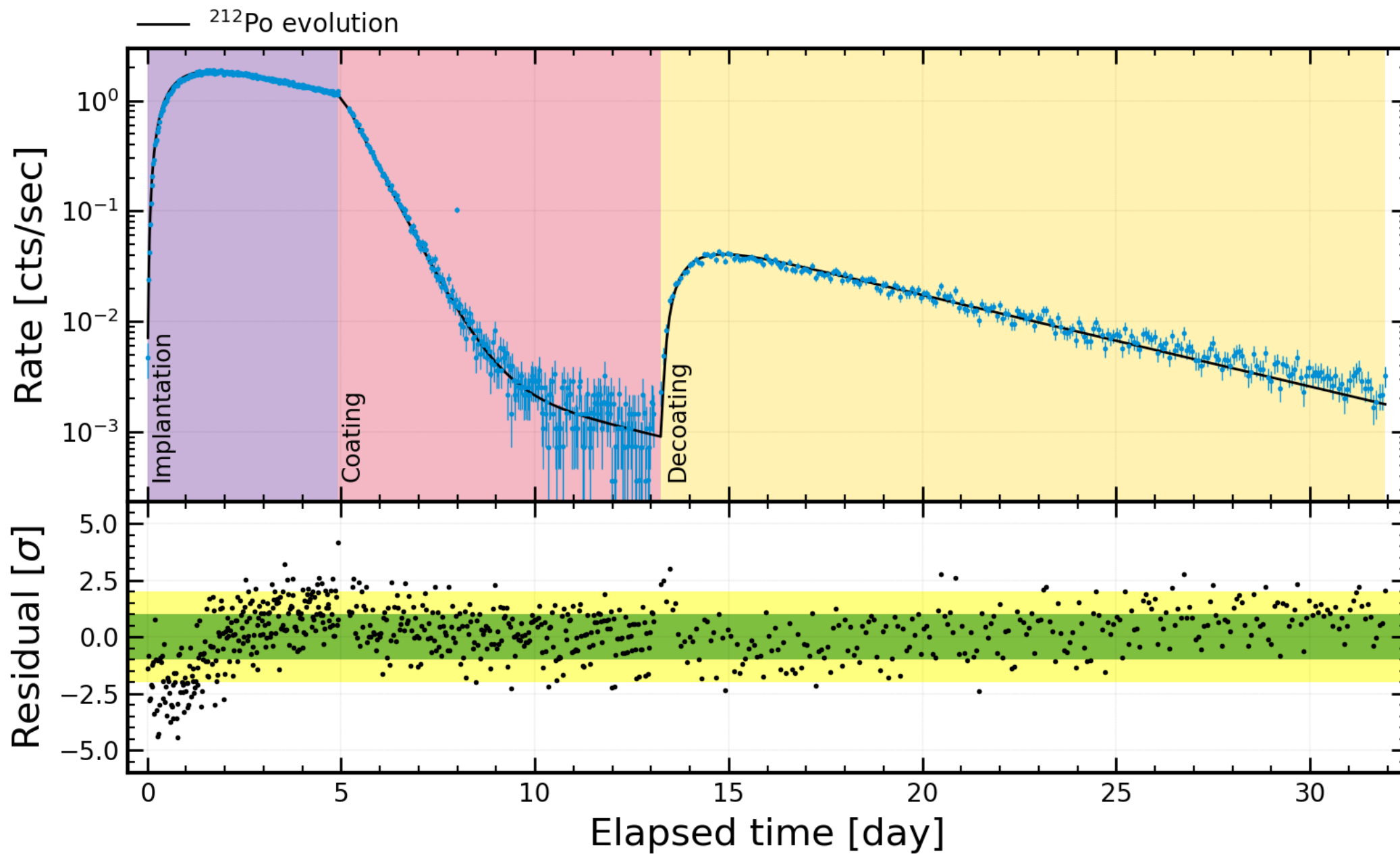
[1] 2 cm x 2 cm x 1 cm

^{220}Rn emanation measurements

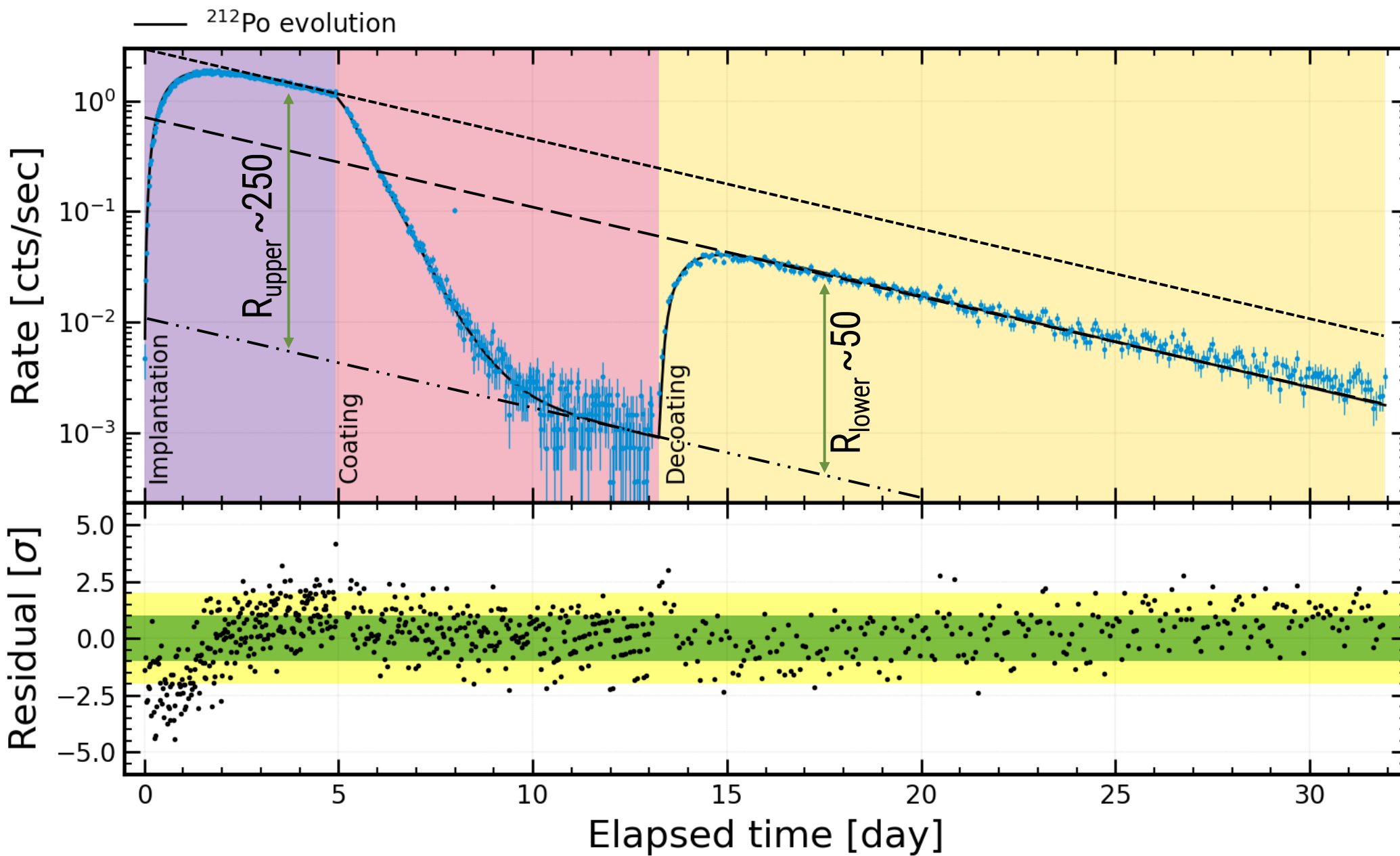
- Three individual radon emanation measurements (\sim one week each): before coating, after coating, after decoating
- The ^{220}Rn emanation rate estimated based on the detected ^{212}Po activity, accounting for the full decay chain (e.g., Bateman equation)



^{212}Po activity evolution

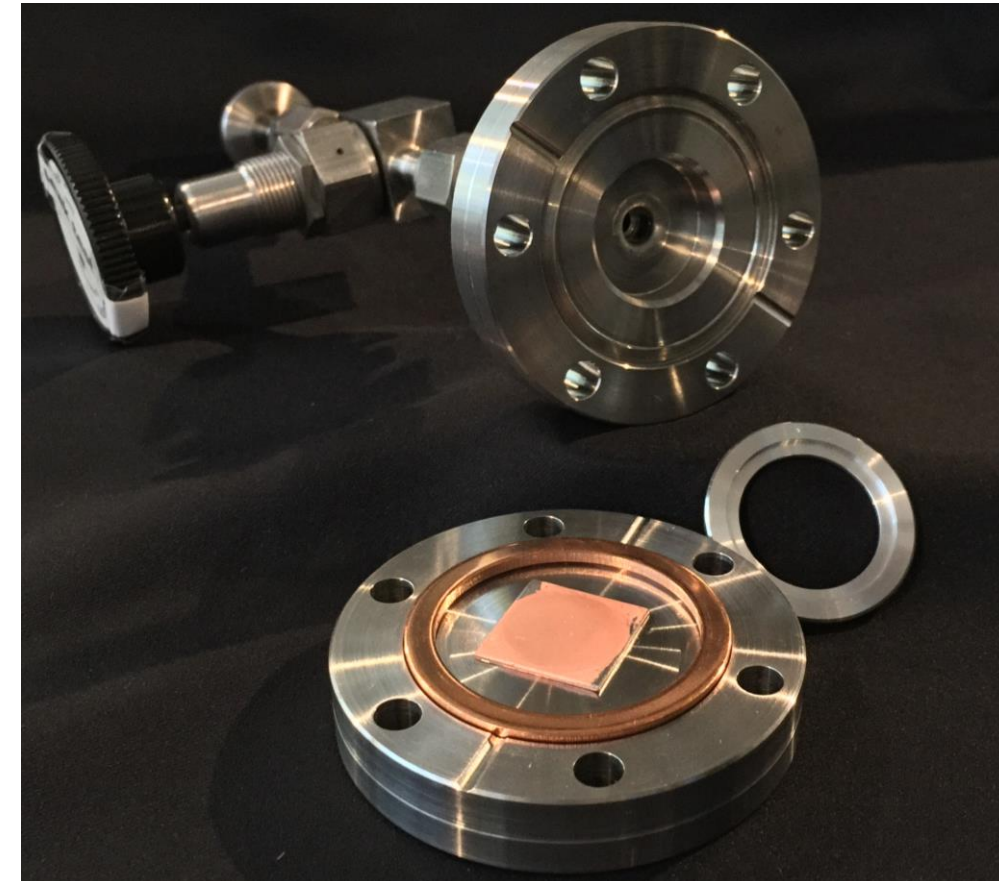
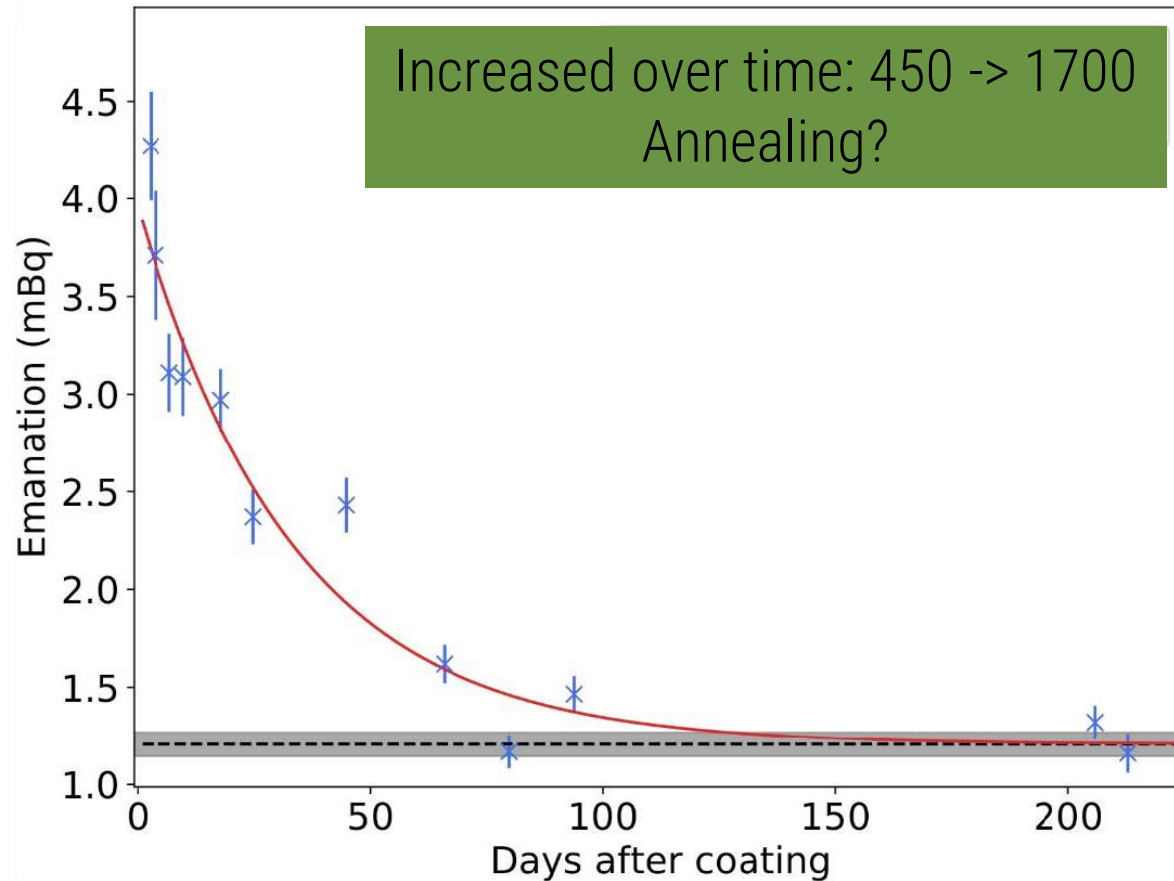


^{212}Po activity evolution



Test on ^{226}Ra implanted sample

- Two stainless steel^[1] ^{222}Rn sources produced at ISOLDE facility in 2017 via implantation of ^{226}Ra
- ~ 8 Bq implanted in 1 cm x 1 cm area at the center, with mean depth of 7.9 nm with a σ_{std} of 2.3 nm
- Unexpected large ^{222}Rn reduction factor!



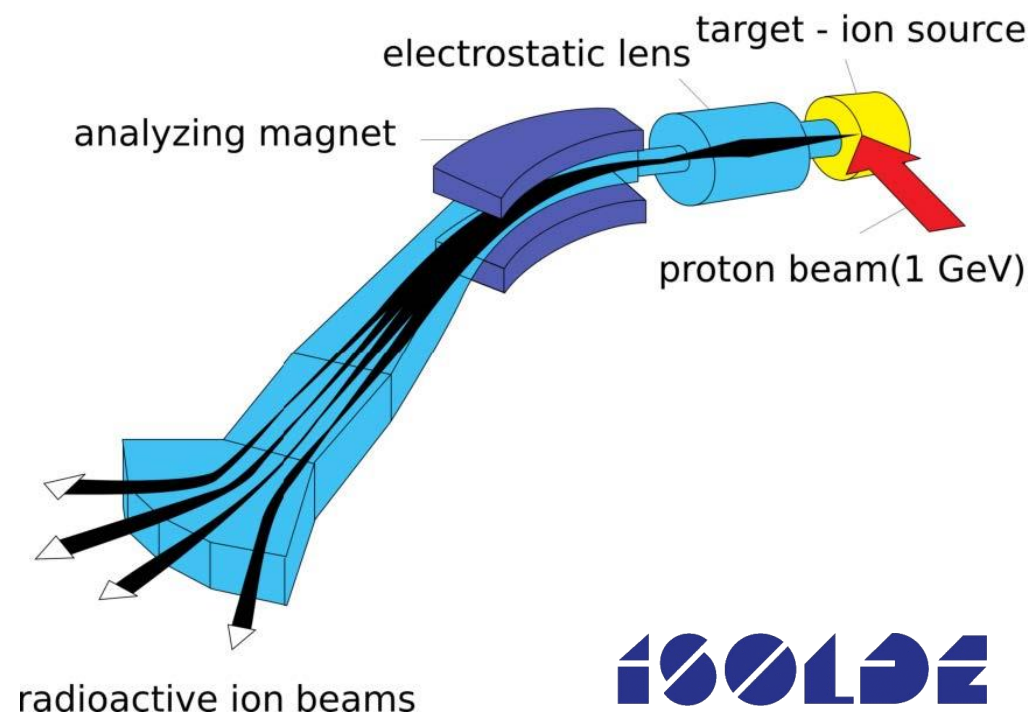
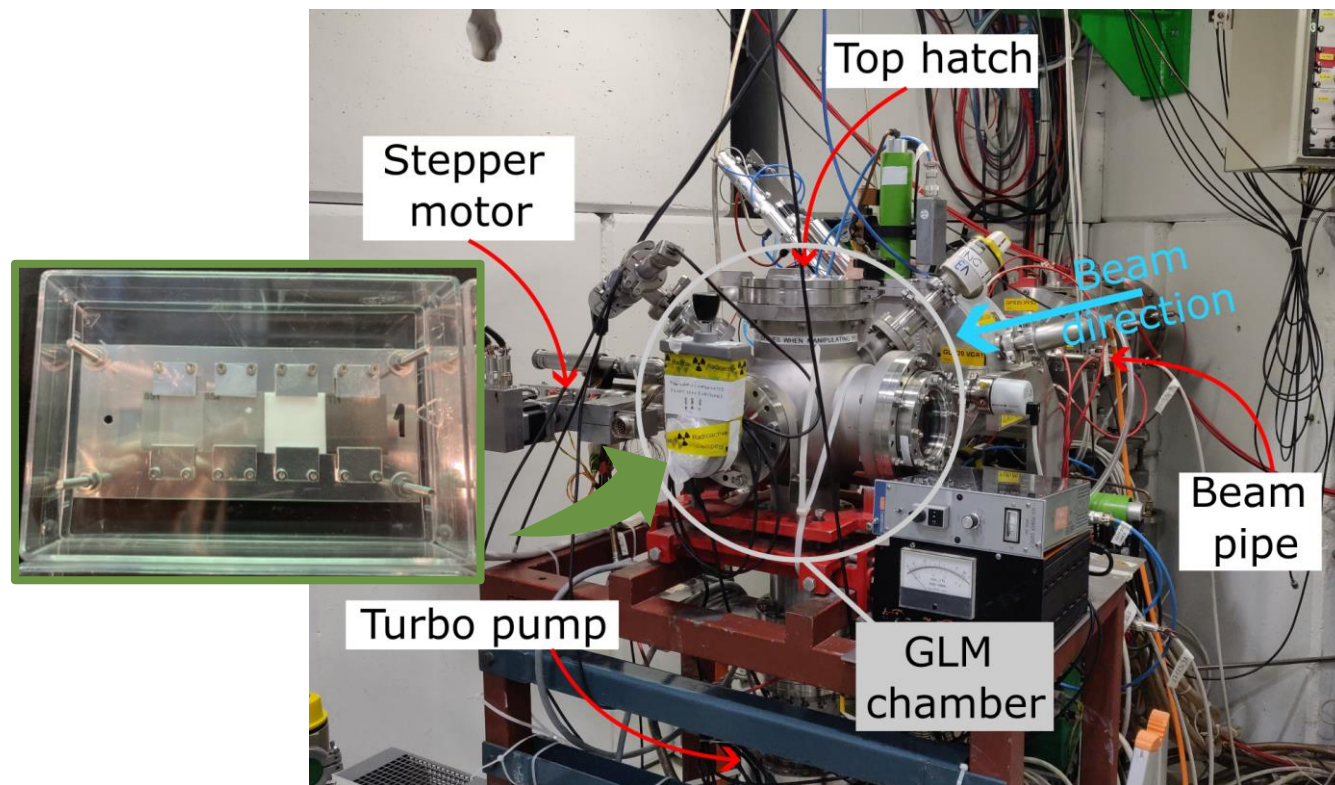
[1] 2 cm x 2 cm x 2 cm

Short term goals:

- Verify ISOLDE ^{222}Rn reduction
- Investigate deeply coating morphology
- Scale up ECP setup
- Characterize further ECP procedure

New ISOLDE implantation campaign

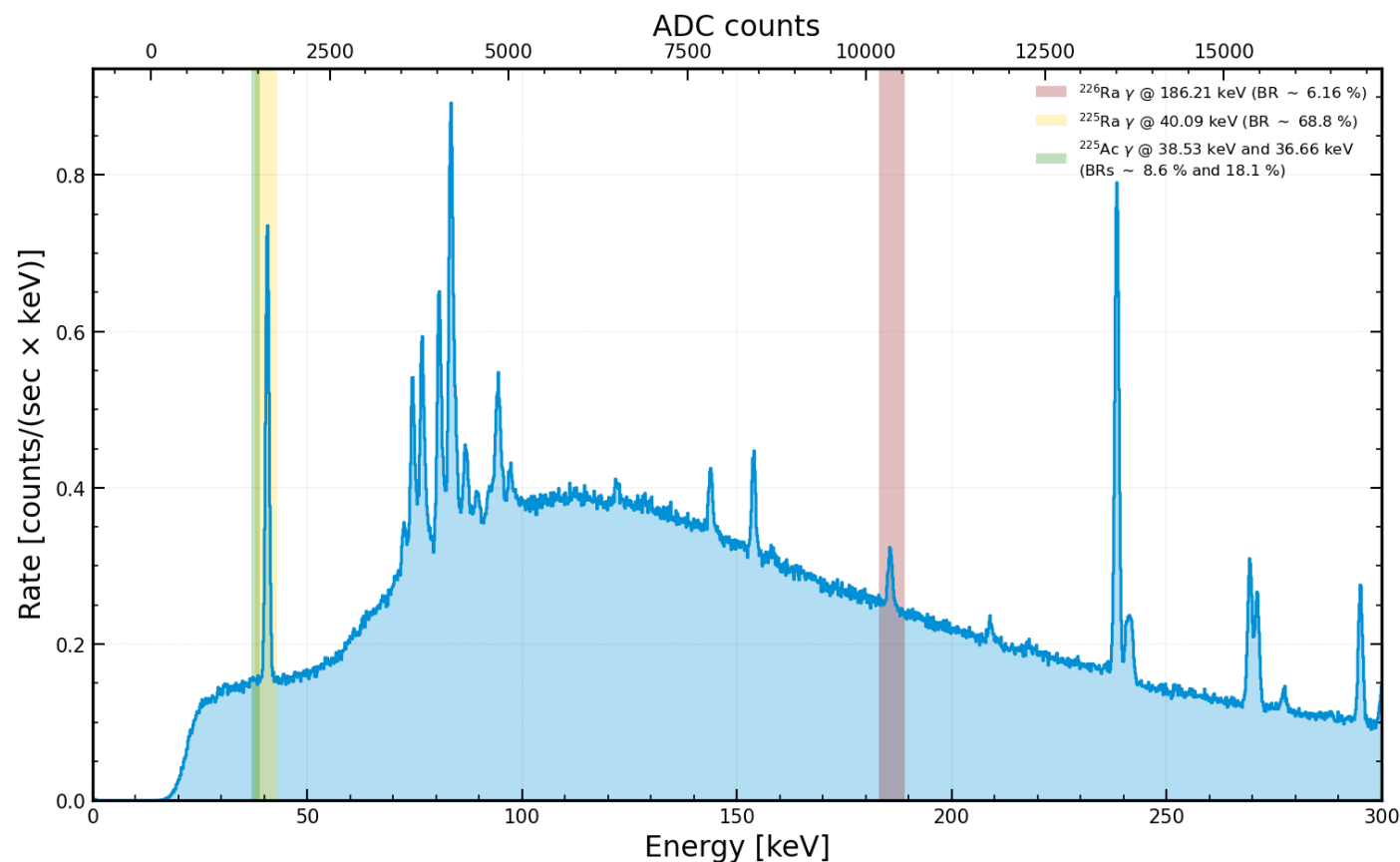
- New ^{226}Ra implantation campaign performed last November
- Not only stainless steel but also other metals (copper, titanium, lead) as well as insulators (PTFE, acrylic, glass) and semiconductors (germanium and silicon)
- 30 keV ^{226}Ra ion beams guided into 2 cm \times 2 cm samples hosted in vacuum chamber



Available radon sources

- Eleven new radon source with up to ~ 4 Bq of ^{226}Ra activity (verified w/ in-situ γ -spectroscopy)
- Sample arrived in February 2024 at MPIK: full characterization started (e.g., α - and γ - spectroscopy, and Rn emanation measurements)

Sample	^{226}Ra ions implanted [$\times 10^{11}$]	^{226}Ra expected activity [Bq]
SS #11	1.5	2.05
Ti #04	3.0	4.1
SS #10	0.03	0.04
Cu #02	3.5	4.8
SS #01	3.0	4.1
SS #02	3.0	4.1
PTFE #01	0.26	0.36
Ti #01	3.1	4.2
SS #07	2.2	3.02
SS #08	//	//
Pb #01	0.15	0.2



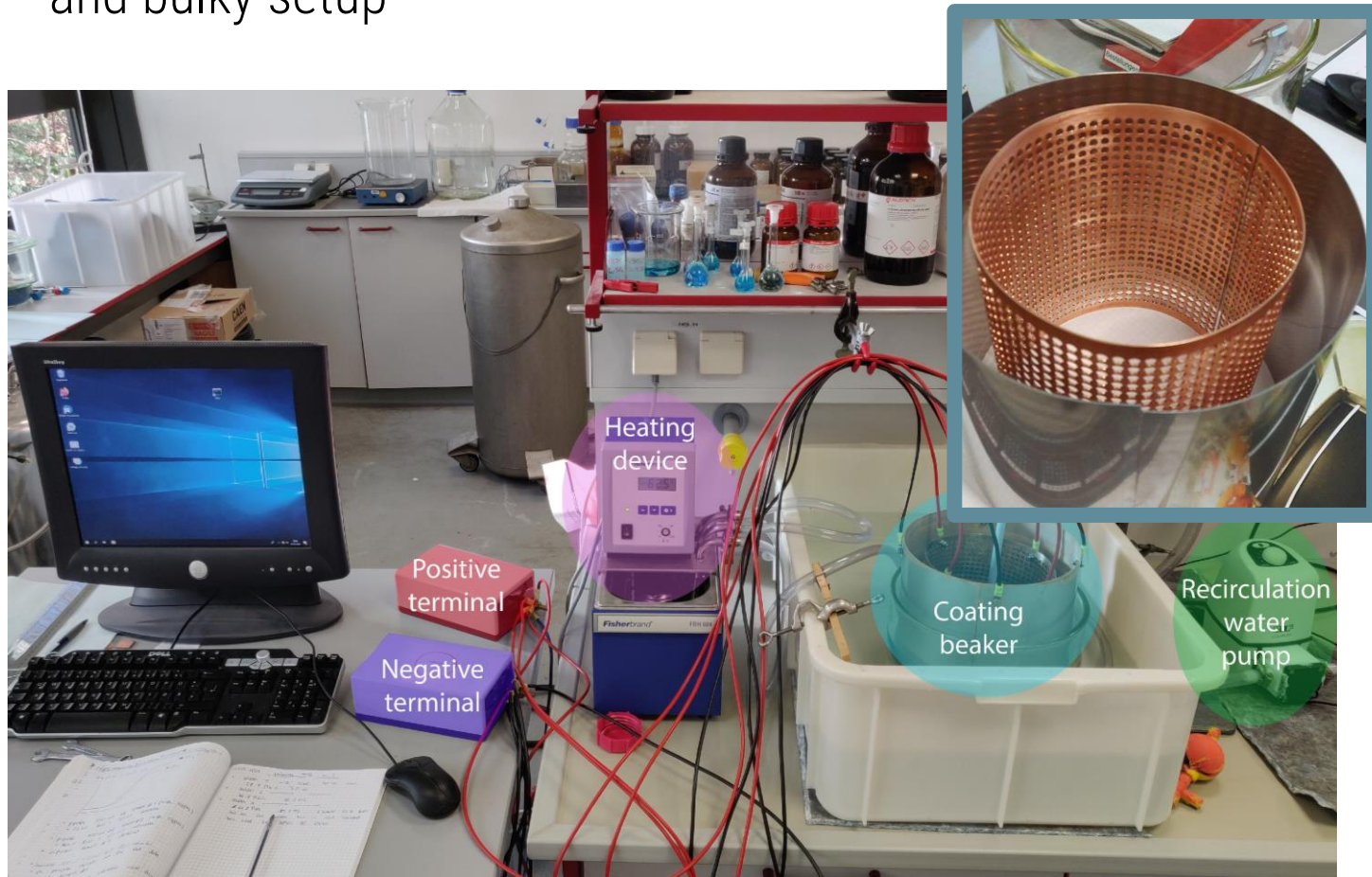
Scaling up ECP setup

- First ECP test with hollow stainless-steel cylinders
- Good mechanical adhesion obtained in all tests (e.g, survived tape test)
- Main limitation: current power supply (Delta Elektronika SM1540-D, $I_{\max}=40$ A) and bulky setup



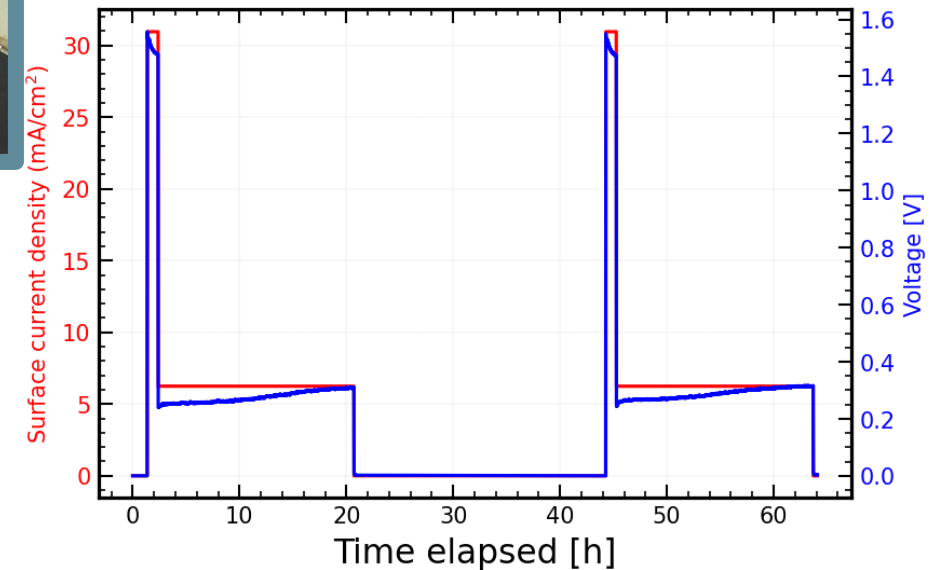
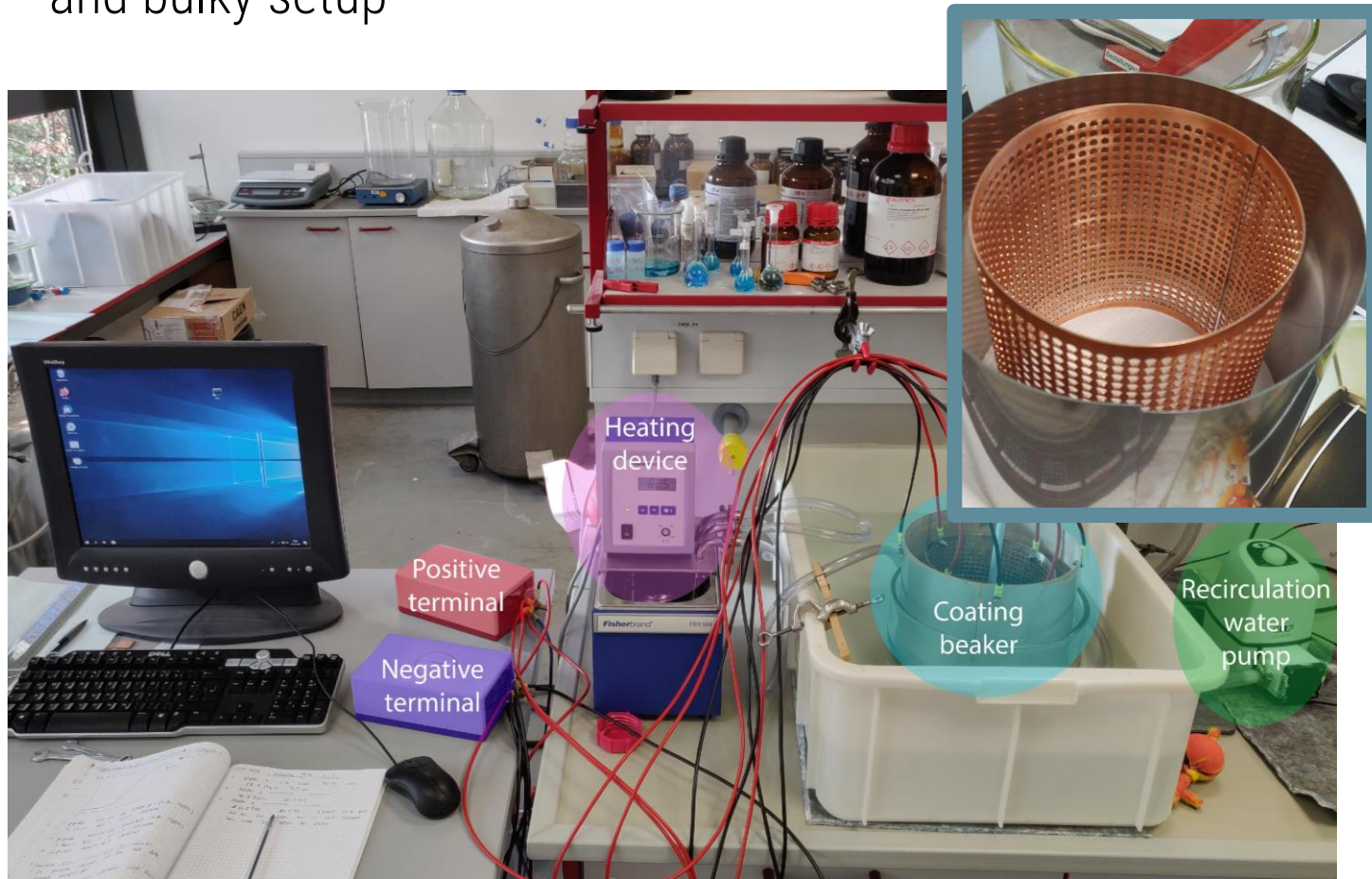
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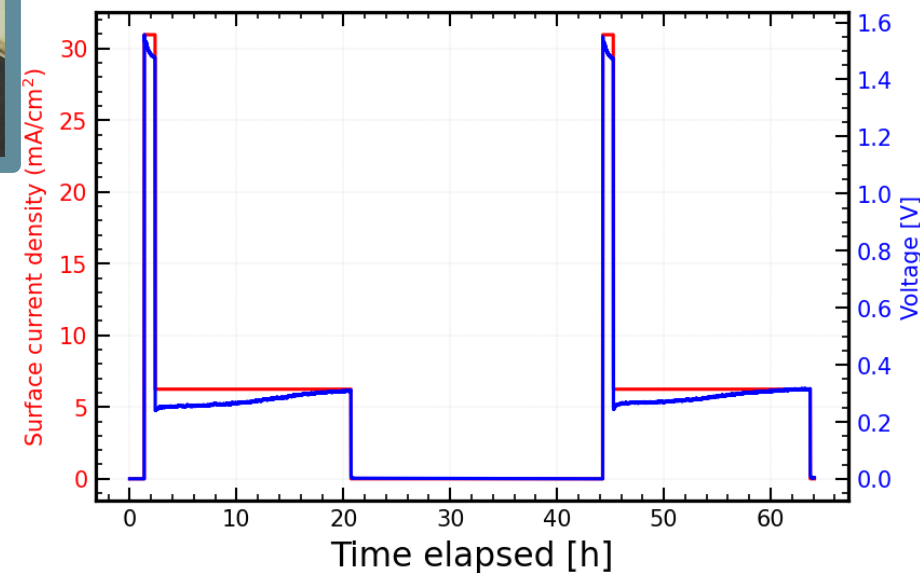
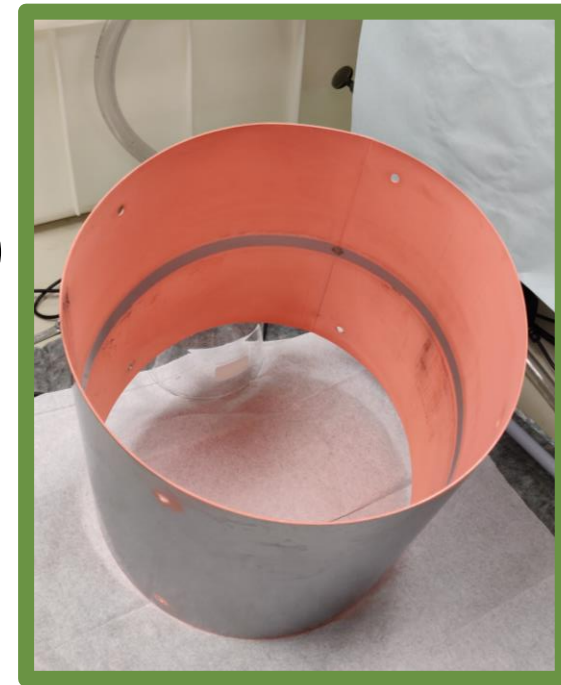
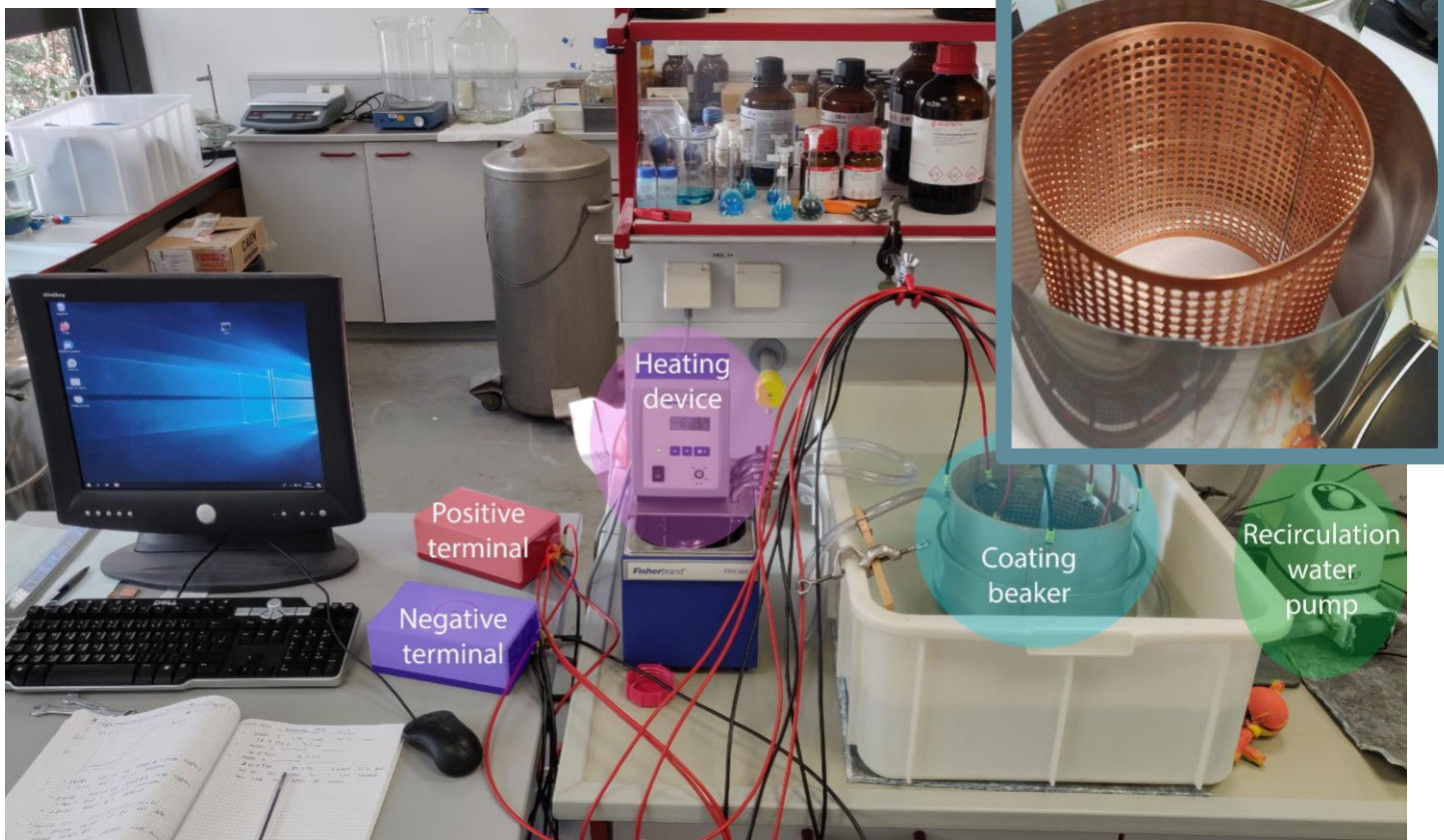
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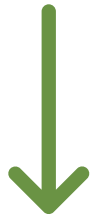
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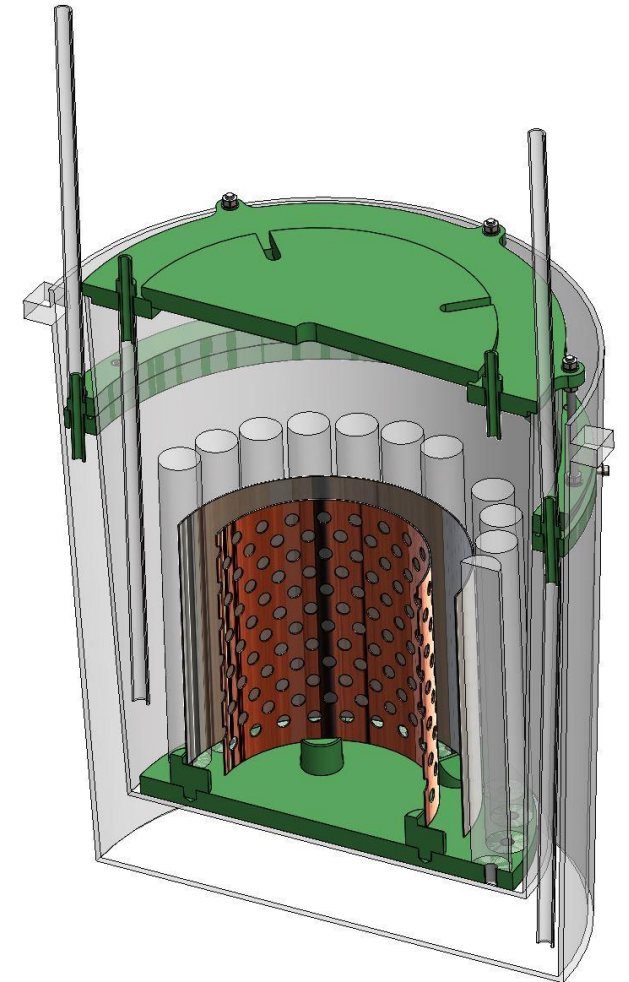
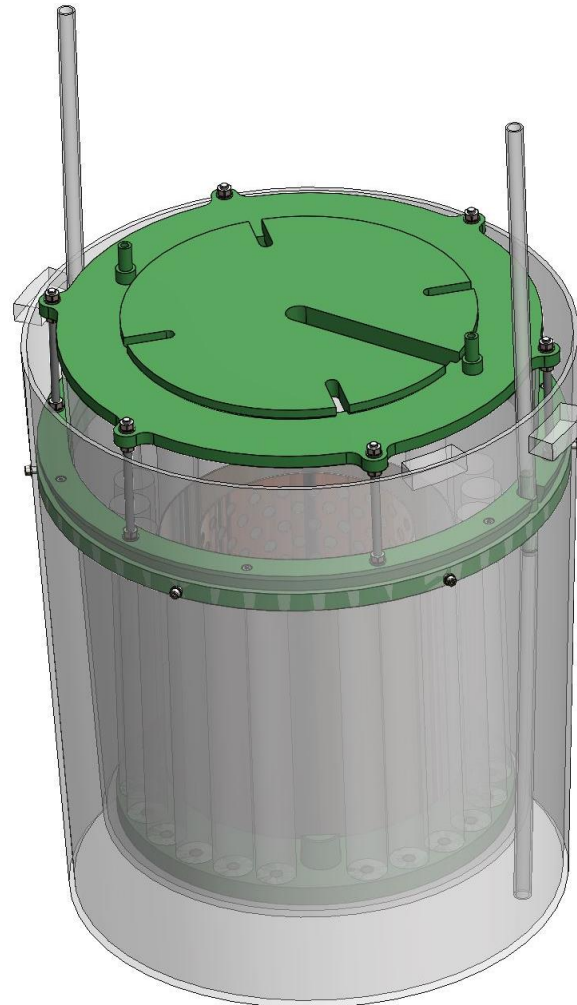


New ECP setup

- New setup in construction at MPIK: ~15-liter double-walled HDPE vessel
- New power supply (EA-PS 8080-510) with current (voltage) output up to 510 A (80 V)
- Perform coating of vessel-like geometry up to 1 m²

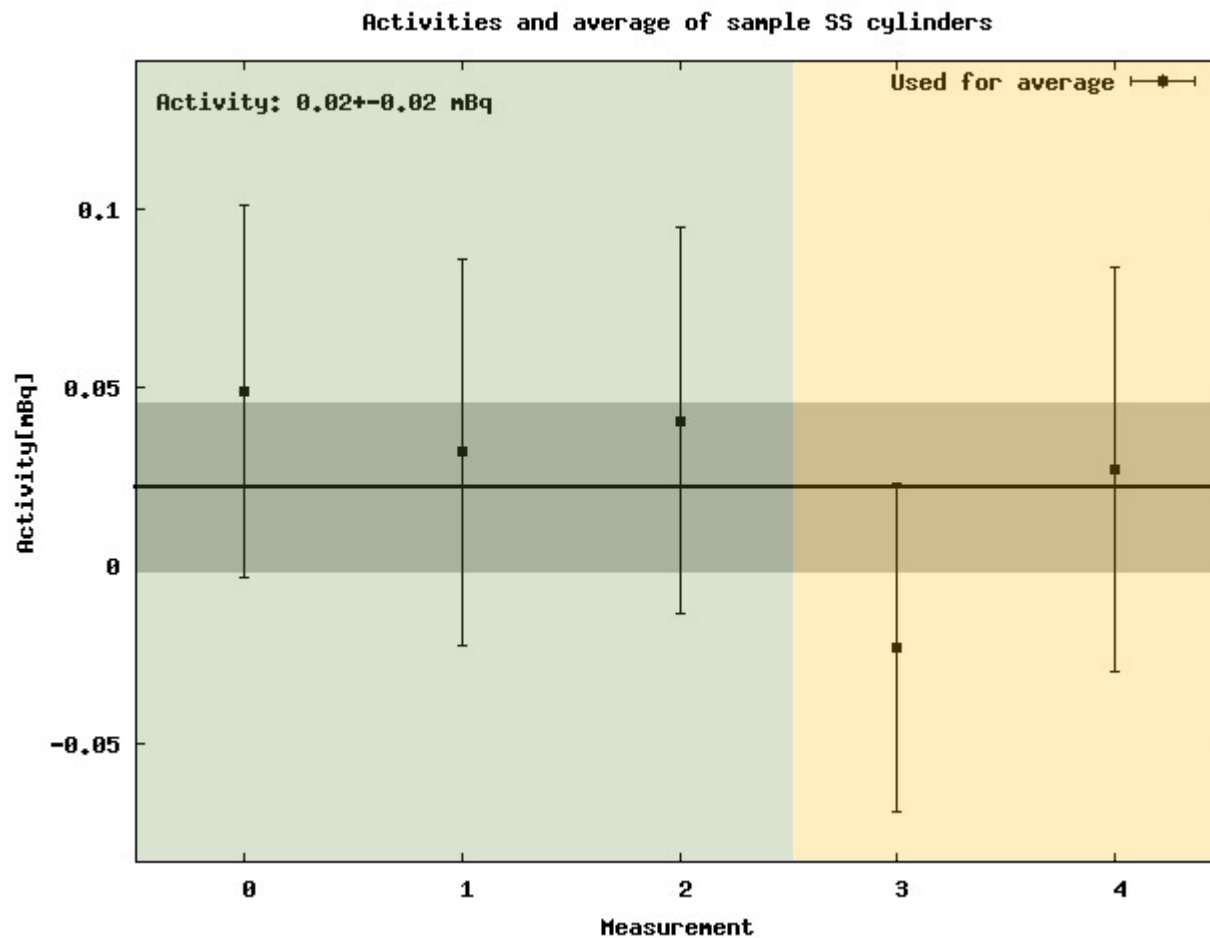


Ultimate goal is to electroplate a radon emanation vessel



Radio purity of the coating layer evaluation

- ^{222}Rn emanation measurements w/ and w/o coating to assert the radio purity of the layer
- Measured performed with proportional counter setup at MPIK
- No evidence of additional Radium: UL at 90% of the Ra introduced is $80 \mu\text{Bq}/\text{m}^2$

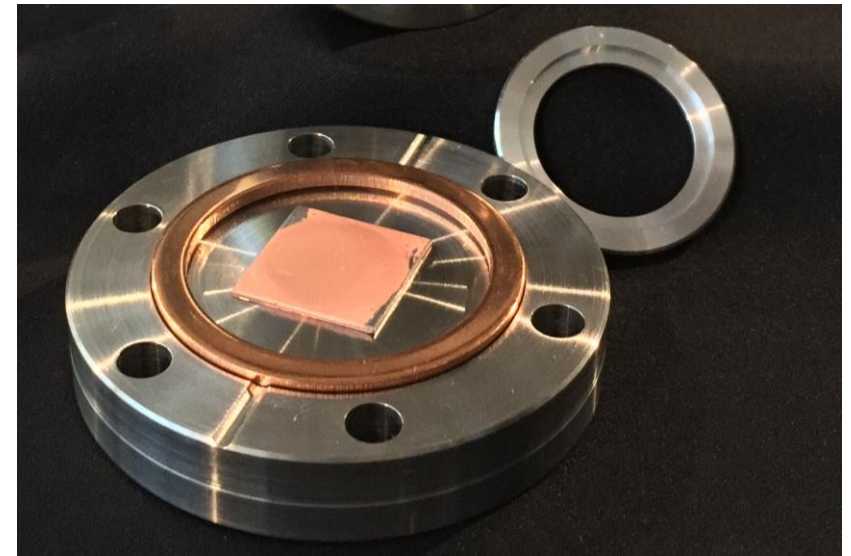
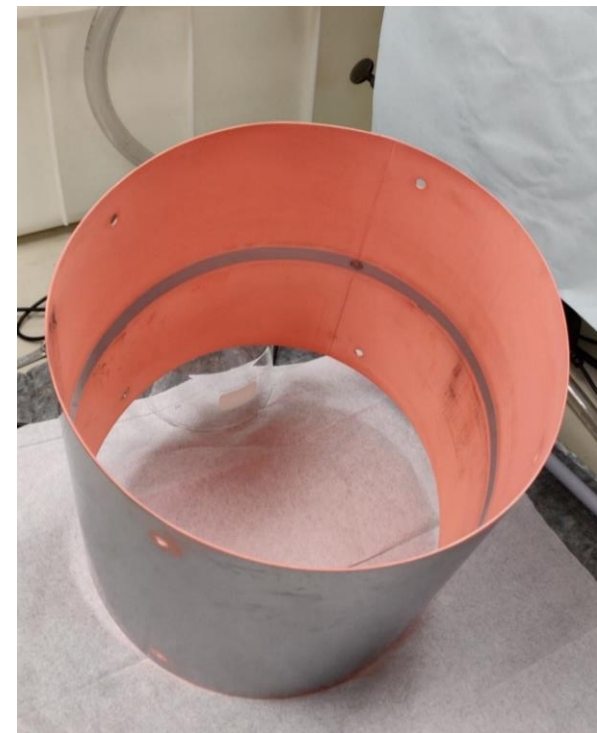


Summary

- Surface coating is a promising technology for Radon background reduction in future dark matter detector
- EPC showed the best reduction results
- New sources available for radon emanation studies
- Proved the scaling up of the setup to reasonable geometries

... what next?

- Characterization of new radon sources and validation of previous reduction results
- Commissioning of new coating setup and coating of vessel-like geometry
- Investigate further coating morphology and EPC procedure



Thank you for the attention!



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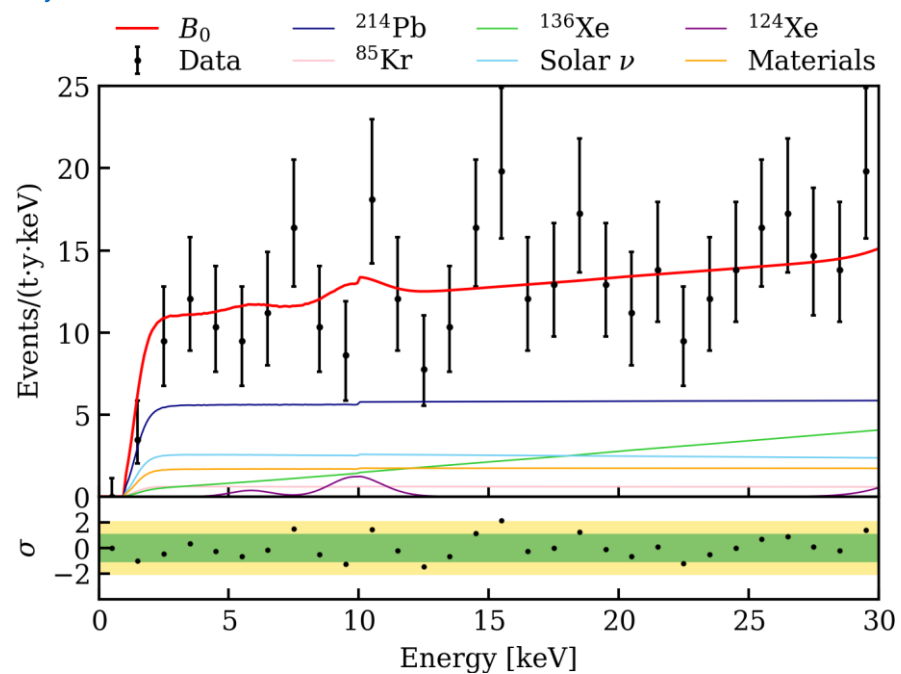


BACK-UP SLIDES

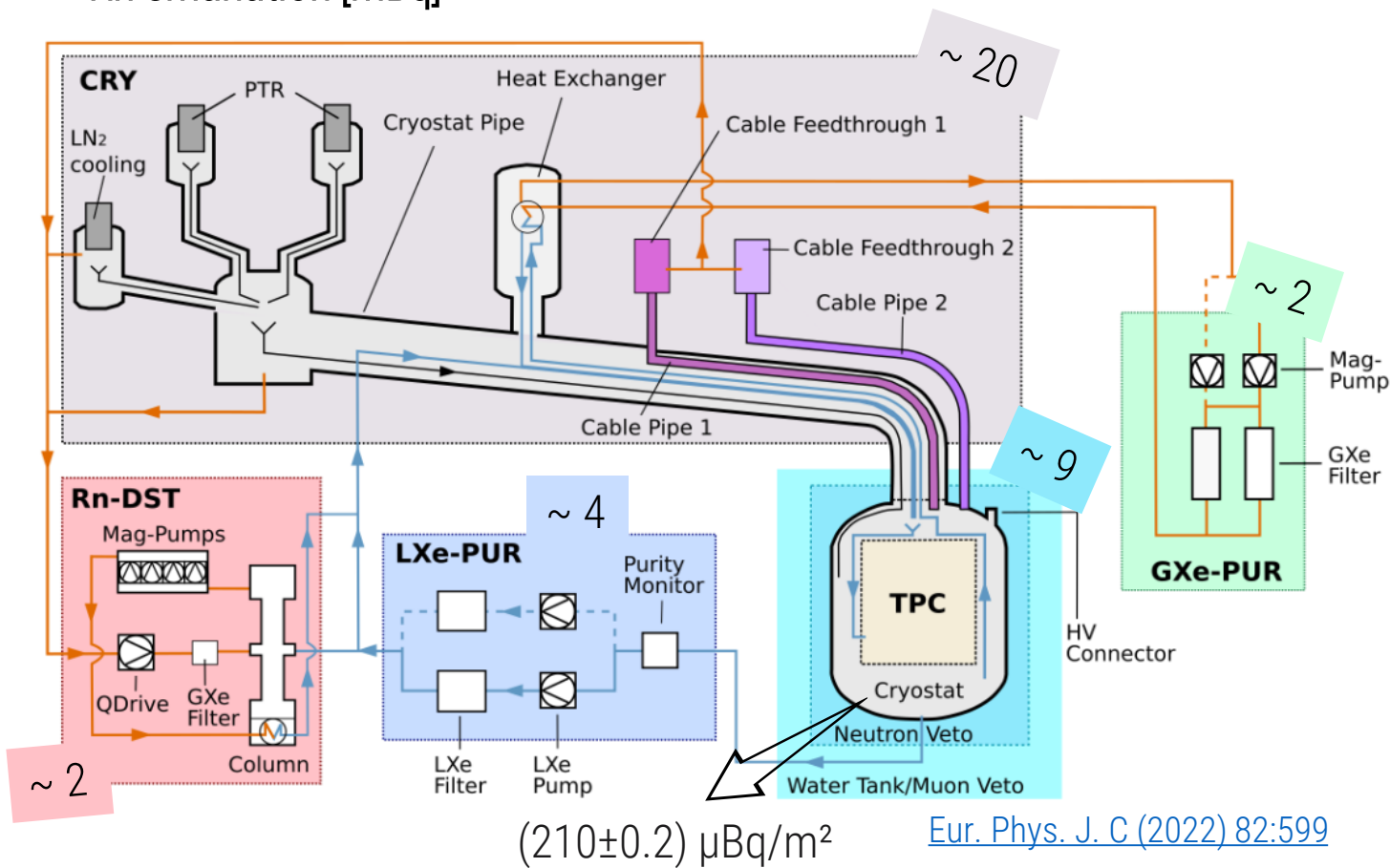
Radon background in XENONnT

- ^{222}Rn is dominant electronic recoil background in XENONnT ($A_{^{222}\text{Rn}} \sim 1 \mu\text{Bq/kg}$ in SR0)
- Radon emanation measurements indicate a various sources distributed over entire experimental infrastructure

[PhysRevLett.129.161805](https://arxiv.org/abs/1905.07621)

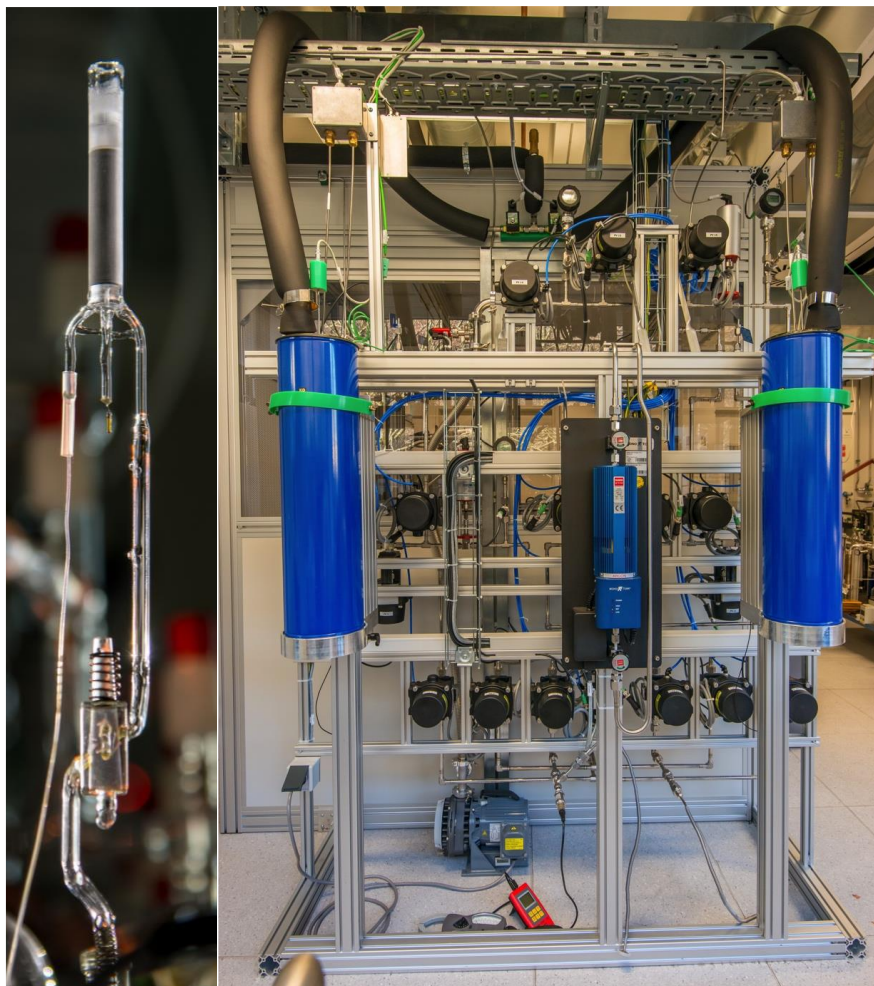


^{222}Rn emanation [mBq]



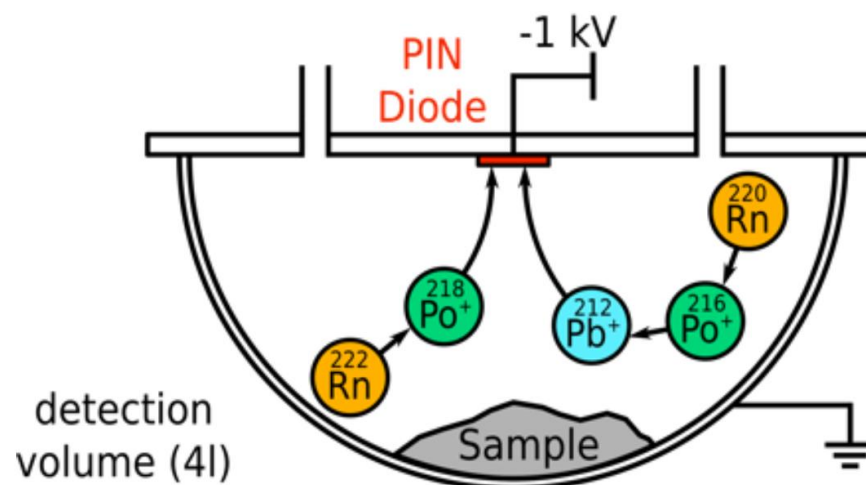
[Eur. Phys. J. C \(2022\) 82:599](https://arxiv.org/abs/2105.07621)

Radon detector at MPIK



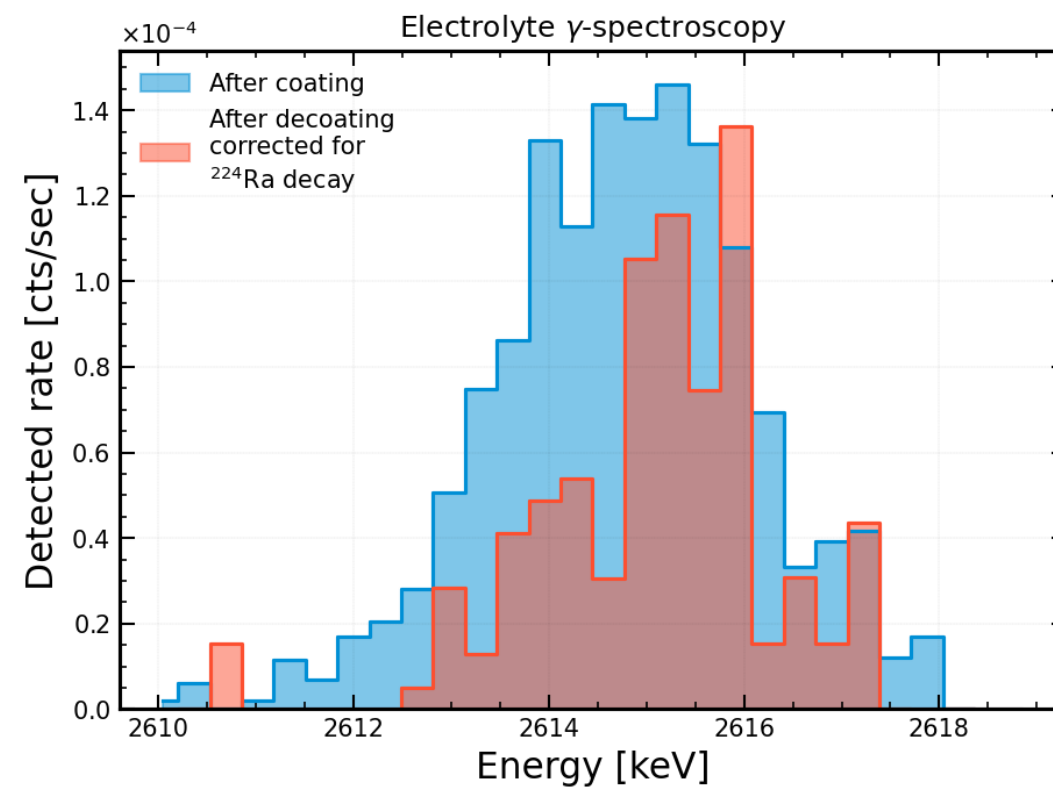
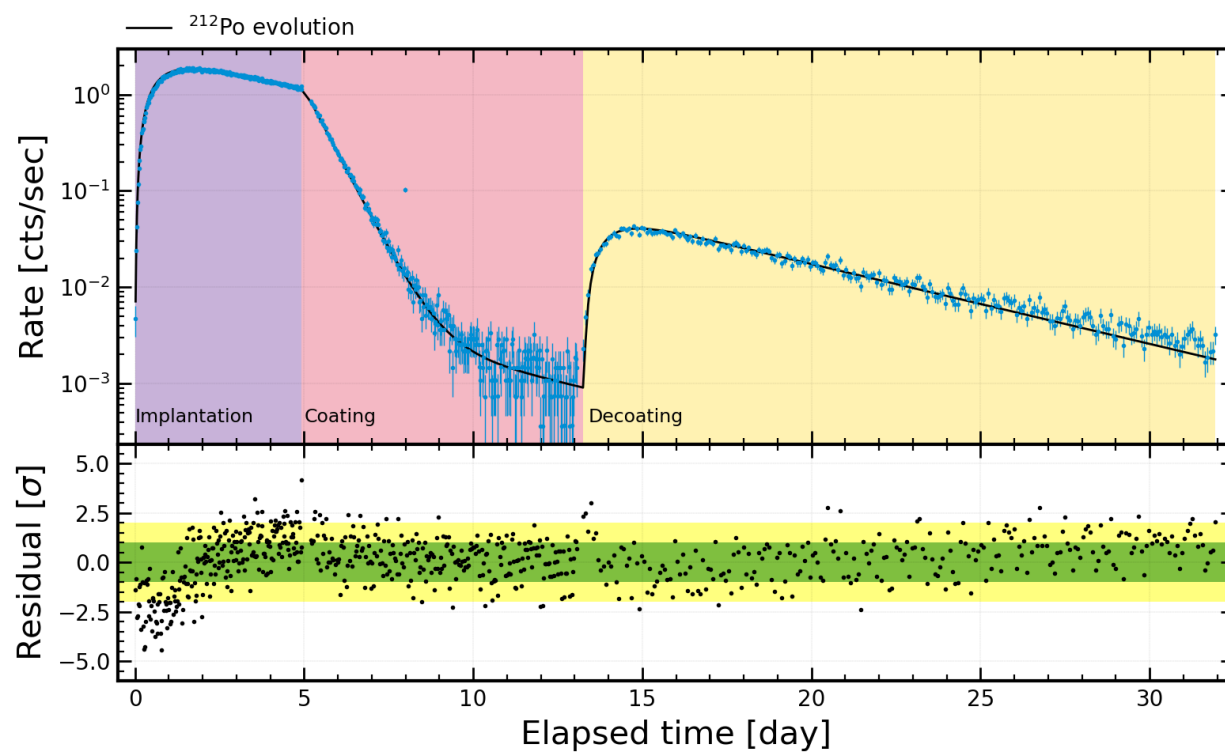
MPIK ^{222}Rn infrastructure:

- >20 ultralow background miniaturized proportional counters
- Sensitivity: ~ 10 atoms.
- 8 parallel counting lines.
- Fully automated ^{222}Rn concentration system (AutoEma).
- ~ 15 sample vessels (0.1 – 80 lit.).
- 3 electro-static ^{222}Rn monitors.



Radon emanation reduction factor

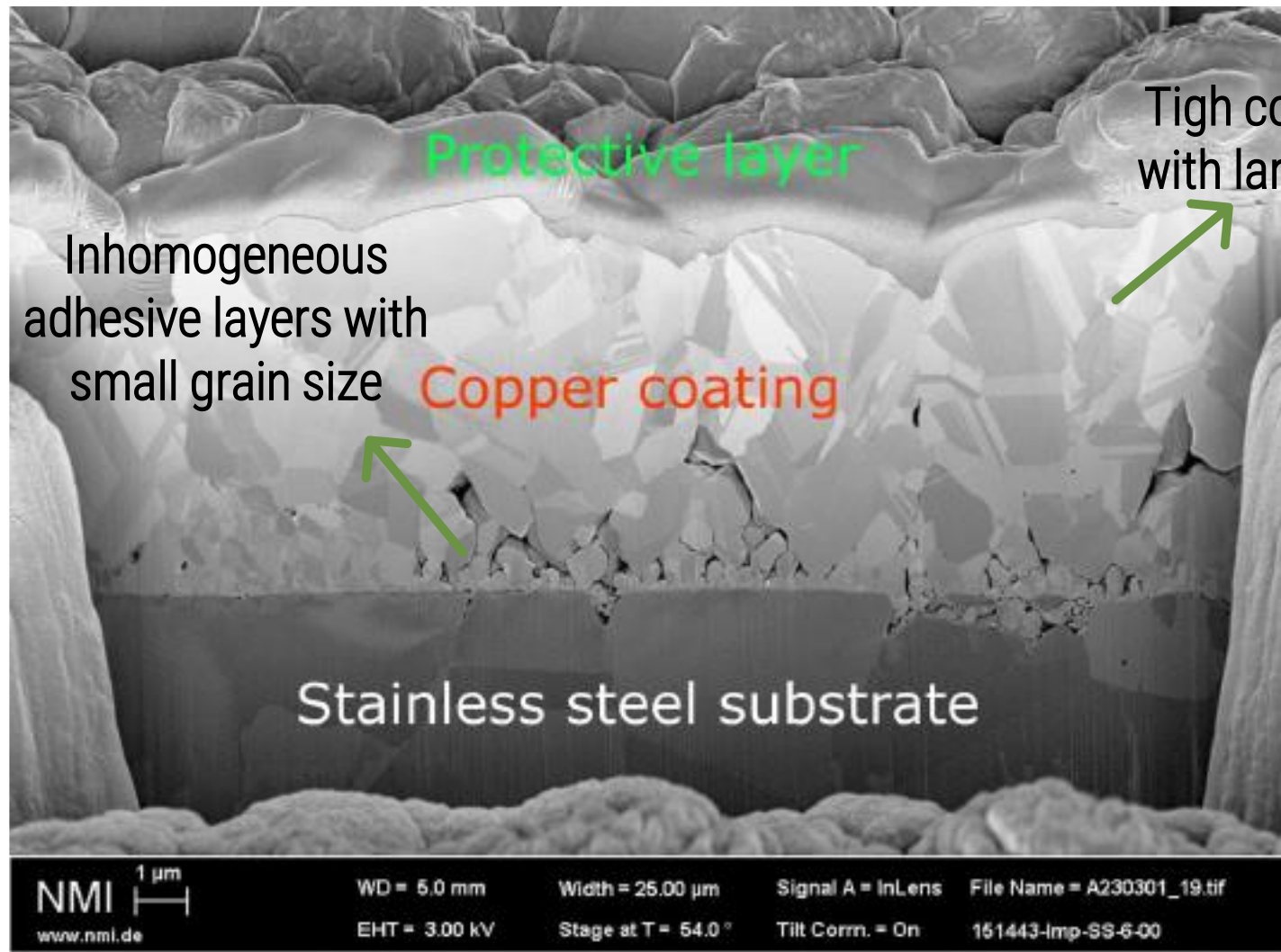
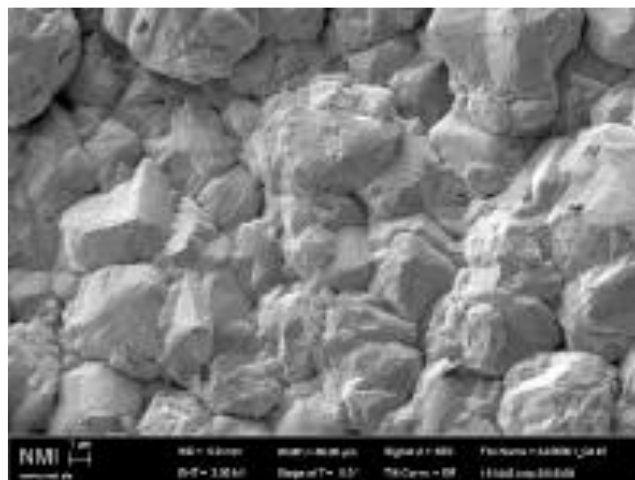
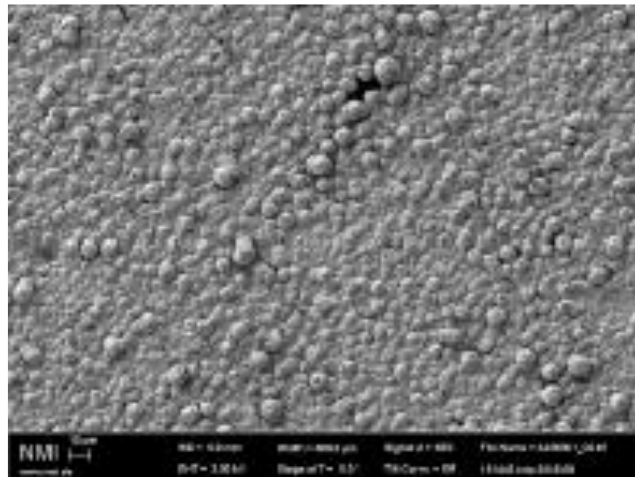
- Performed Ge spectroscopy of the electrolyte after coating and decoating: monitor ^{208}Tl γ line
- True reduction factor $\in [R_{\text{lower}}, R_{\text{upper}}] \rightarrow 50 \leq R \leq 250 !$



Coating morphology

- Secondary Electron Microscopy (SEM) investigation of coating

Rough surface with spherical structures



Tight cover layer with large grains

Protective layer

Inhomogeneous adhesive layers with small grain size

Copper coating

Stainless steel substrate